



10/681,481

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	PAUL A. FARRAR	Examiner:	Michail Kornakov
Serial No.:	10/681,481	Group Art Unit:	1746
Filed:	October 8, 2003	Docket:	1303.112US1
Title:	METHOD OF CLEANING SEMICONDUCTOR SURFACES		

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**RESPONSE TO RESTRICTION REQUIREMENT**

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

In response to the Restriction Requirement mailed October 10, 2006, Applicant submits the following.